



FORM PTO-1449 (Rev. 7-80)		U.S. Dept. of Commerce Patent and Trademark Office		Atty Docket No. 24096.00800		Serial No. 09/675,278													
INFORMATION DISCLOSURE CITATION (Use several sheets if necessary)																			
<table border="1"> <tr> <td colspan="2"></td> <td colspan="2">Applicant Kozlowski, Lester J., et al.</td> <td colspan="2"></td> </tr> <tr> <td colspan="2"></td> <td colspan="2">Filing Date September 29, 2000</td> <td colspan="2">Group 2878</td> </tr> </table>										Applicant Kozlowski, Lester J., et al.						Filing Date September 29, 2000		Group 2878	
		Applicant Kozlowski, Lester J., et al.																	
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*Examiner: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Drawn through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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